

DESCRIPTION	MATERIAL	MAT. LOCATION



1. UNITS ARE IN MILLIMETERS.

					UNLESS OTHERWISE SPECIFIED		SHOP ORDERS		SER NO.	ERNEST ORLANDO LAWRENCE						
					X.X ± 2.5 FRAC. ± 1/64		ACCT NO. NO REQD		DATE ISSD	BERKELEY NATIONAL LABORATORY						
					X.XX ± .25 ANGLES ± 30°		DEL TO		DATE RECD	UNIVERSITY OF CALIFORNIA - BERKELEY						
					X.XXX ± 0.13 FINISH -		SURFACE TREATMENT			1m STAVE ASSEMBLY (12cm WAFER)						
					DO NOT SCALE PRINT		IDEN METHOD TAG									
					THREADS ARE CLASS 2		PROJECT NUMBER									
					CHAMFER ENDS OF ALL SCREW THREADS 30°		PROJECT NAME		ATL-IP-ED-XXXX	DO NOT SCALE PRINTS						
					CUT ROUND, 1.5 THREAD RELIEF ON MACHINED THREADS		US ATLAS SILICONE SUBSYSTEM		MICROFILMED:	DWG. TYPE	SHOWN ON	SCALE: 1:2	DO NOT SCALE PRINTS			
					BREAK EDGES .016 MAX. ON MACHINED WORK		DWG BY W. K. MILLER		DATE 7/6/2006	PART	nnXnnn	SHEET 1 OF 1				
					REMOVE BURRS, WELD SPATTER & LOOSE SCALE		CHK BY W. O. MILLER		DATE 7/6/2006	PATENT CLEAR:	DESIGN ACCT. NO.	CATEGORY CODE	DWG. NO.	SIZE	REV.	
					IN ACCORDANCE WITH ASME Y14.5m & B46.1		APR -		DATE -	P1AP-11	AP6250	nnXnnnn4			1	
REV	DWG	CHK	ZONE	DATE	CHANGES											